01-14-02

25 Metro Drive

San Jose California 95110 T: 408-453-9200 F: 408-453-7979 Austin, TX Newport Beach, CA San Francisco, CA

skjerven morrill

Docket No.: M-11749-4D US

January 11, 2002

Re:

Applicant(s):

hissioner For Patents shington, D.C. 20231

Cohen, Adam L.

Assignee:

University of Southern California

Title:

Method For Electrochemical Fabrication

Serial No .:

09/493,496

Examiner:

E. Smith-Hicks

Filed:

January 28, 2000

Docket No.:

M-11749-4D US

Group Art Unit: 1741

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

itted herewith are the following documents in the above-identified application:

(1) Return Receipt Postcard;
(2) This Transmittal Letter (in duplicate);
(3) Request for Additional Amendments (4 pages);
(4) Request to Amend Drawings Under 37 CFR § 1.21(2 pages);
(5) Information Disclosure Statement Under 37 CFR § 1.97 with Fee (1 page) (in duplicate)

(6) PTO 1449 (1 page); and

No additional fee is required. The fee has been calculated as shown below:

CLAIMS AS AMENDED (fees computed under 37 CFR §1.9(f))

		Claims Remaining After Amendment		Highest No. Previously Paid For		Present Extra		Rate		Additional Fee
Total Claims		12	Minus	20	= '	0	x	\$ 9.00	\$	0.00
Independent Claims		3	Minus	3	=	0	х	\$42.00	\$	0.00
\boxtimes	Information Disclosure Statement Under 37 CFR § 1.97 with Fee								\$	180.00
	Total additional fee for this Amendment:								\$	<u>180.00</u> 4.5
\boxtimes	Conditional Petition for Extension of Time: If an extension of time is required for timely filing of the enclosed document(s) after all papers filed with this transmittal have been considered, an extension of time is hereby requested.									
\boxtimes	Please charge our Deposit Account No. 19-2386 in the amount of								\$	0.00
\boxtimes	Also, charge any additional fees required and credit any overpayment to our Deposit Account No. 19-2386.									

EXPRESS MAIL LABEL NO .: EL 884 818 915 US

Respectfully submitted,

Total:

180.00

Attorney for Applicant(s)

Reg. No. 33,003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Cohen, Adam L.

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Method For Electrochemical Fabrication

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RECEIVED

San Jose, California January 11, 2002

COMMISSIONER FOR PATENTS Washington, D. C. 20231

TO 4 ==

REQUEST FOR ADDITIONAL AMENDMENTS

Dear Sir/Madam:

This is a supplement to a Response to Office Action filed on November 20, 2001. Applicant respectfully requests entry of amendments as set forth below.

IN THE DRAWINGS

Please amend FIG. 20 as indicated in red on the enclosed marked up version of FIG. 20.

IN THE SPECIFICATION

In accordance with 37 C.F.R. §1.121(b)(3)(iii), Attachment A contains a marked up version of the amended paragraph indicating the newly introduced change.

Please replace the paragraph starting on page 15, line 23 with the following paragraph:

LAW OFFICES OF SKJERVEN MORRILL MACRIERSON LLF

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The micromold surface including the photoresist and the substrate can be passivated by allowing the micromold to be exposed to vapors of, e.g., (tridecafluoro-1,1,2,2-tetrahydrooctyl)-1-trichlorosilane, (commercially available from United Chemical

834808 v1 / PF-OA [Rev. 000913]

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